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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: KOEMTZOPOULOS et al.

Attorney Docket No.:
LAM1P186/P1211

Application No.: 10/803,342

Examiner: PAGE, Thurman K.

Filed: March 17, 2004

Group: 1615

Title: DUAL DOPED POLYSILICON AND
SILICON GERMANIUM ETCH

Confirmation No.: 5586

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as first-class mail on March 15, 2006 in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Signed: _____

Sue Funchess
Sue Funchess

REQUEST FOR STATUS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicants hereby request status of the above-referenced patent application. This application was filed on March 17, 2004, and no response has been received as of this date.

Respectfully submitted,

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